

Partial oxidation of methane to H₂ and CO over Rh/SiO₂ and Ru/SiO₂ catalysts

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Abstract

Partial oxidation of methane to syngas (POM) over Rh/SiO₂ and Ru/SiO₂ catalysts was investigated at 450–800 °C. Methane conversion and selectivity to both H₂ and CO were higher over Rh/SiO₂ than over Ru/SiO₂. The CO and H₂ selectivities substantially decreased with increasing GHSV over Ru/SiO₂ at 500 °C, while these selectivities remained nearly constant over Rh/SiO₂. Both the CH₄ conversions and the CO and H₂ selectivities increased slightly over Rh/SiO₂ at 700 °C as GHSV increases, while the CH₄ conversions and the CO and H₂ selectivities decreased slightly over Ru/SiO₂. Pulse reactions, transient reactions, and in situ microprobe Raman techniques were employed to investigate the oxidation of methane over Rh/SiO₂ and Ru/SiO₂ catalysts. CO was the main product when Rh/SiO₂ was exposed to methane pulsing at 700 °C. No CO₂ was detected during the first pulse over the Rh/SiO₂ catalysts. However, CO₂ was formed in every pulse over Ru/SiO₂. Transient results showed that CO was formed prior to CO₂ generation over Rh/SiO₂ catalysts. CO₂ was the primary product over Ru/SiO₂ catalysts. In situ microprobe Raman spectroscopy at 450–600 °C demonstrated that Ru/SiO₂ surfaces contained significantly larger amounts of metal oxide species than Rh/SiO₂ during the POM reaction. The mechanisms of POM over the two catalysts are different. A direct oxidation process mainly occurs over the Rh/SiO₂ catalyst, while the dominant pathway over the Ru/SiO₂ catalyst is the indirect oxidation process.

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1. Introduction

The greenhouse effect and the limited reserves of fossil fuels have encouraged studies of CO₂-neutral and renewable energy sources. One alternative energy source is hydrogen, which can be used to generate both electricity and heat in high efficiency fuel cells. Hydrogen is targeted as the next generation fuel since it produces water instead of CO₂. Fuel cell technology and high-pressure hydrogen tank storage are already in advanced development stages [1–4]. Several

techniques are available for hydrogen production from hydrocarbons including steam reforming which is generally accompanied by a water gas-shift conversion and a hydrogen purification process. Steam reforming [SR, Eq. (1)] has constituted the dominant commercial process employed to produce synthesis gas from methane over the past several decades [5]:

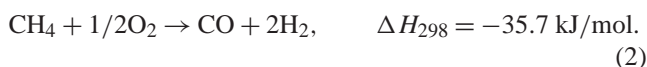


However, this process requires a large energy input and very complex processing. Therefore, to obtain hydrogen at a lower energy input, the partial oxidation of methane [POM, Eq. (2)] to hydrogen and carbon monoxide which was first studied by Prettre et al. [6] has been studied intensively in

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the past decade [7–22]:



Partial oxidation of methane (POM) to syngas is slightly exothermic and more energy efficient than steam reforming of CH_4 . A smaller reactor can be used to achieve high CH_4 conversion and selectivity to H_2 with short contact times ($\sim 10^{-3}$ s) [23]. Furthermore, POM is mechanically simpler than the steam reforming, since it is completed in a single reactor, without external heating. However, several problems must be solved before POM can be developed on the industrial scale. These include the cofeeding of CH_4/O_2 under explosive conditions [11], and the formation of local hot spots within catalyst beds that can irreversibly damage both the catalyst and the reactor [11,12]. Carbon deposition may deactivate the catalysts [13,14]. Therefore, understanding the reaction mechanism and the nature of the active catalytic sites is important. Despite many past studies of the partial oxidation of methane to syngas, engineering problems (heat and mass-transfer control) must still be solved and catalysts must be improved [14]. Thus, a better understanding of mechanisms and microkinetics is required [15].

Two major POM reaction mechanisms have been proposed. One involves total oxidation of a portion of the CH_4 followed by reforming the unconverted CH_4 with CO_2 and H_2O to produce CO and H_2 . This was proposed by Prettre et al. [6]. The other scheme, proposed by Schmidt et al. [17,18], postulates direct partial oxidation of CH_4 to CO and H_2 without the production of CO_2 and H_2O . Schmidt et al. also found that the POM reaction process is mass-transfer limited [19–22] and examined the role of boundary layer mass transfer on the selectivity during partial oxidation of CH_4 oxidation to CO and H_2 over Pt–Rh gauzes and Pt-coated ceramic monoliths [19,20]. This selectivity is strongly affected by the gas-flow rate and the catalyst geometry. Schmidt et al. concluded that mass transfer across the boundary layer over a catalyst surface strongly influences reactor selectivity for fast reactions. Several variables during H_2 and CO production were examined. Selectivity was improved by operating at higher gas and catalyst temperatures by maintaining high rates of mass transfer through the surface boundary layer and by using catalysts with high metal loadings. High flow rates minimized mass-transfer limitations, causing gauze, foam monoliths, and extruded monoliths to give similar selectivities and conversions. However, important differences resulted from different catalyst geometries and thermal conductivities.

Supported noble metal catalysts are mainly used for the POM reaction, including Rh, Ru, Pd, and Pt [24–27], and supported Ni catalysts [28–30]. The type of catalyst employed may strongly influence the reaction steps of catalytic POM. Elmasides and Verykios [31] investigated the partial oxidation of methane to synthesis gas over Ru/TiO_2 employing non-steady-state and steady-state isotopic transient experiments, combined with in situ DRIFT spectroscopy.

Gas-phase CH_4 interacts with the catalyst surface, producing CH_x surface species. Elmasides and Verykios determined that CO is the primary product, resulting from a surface reaction between carbon and adsorbed atomic oxygen on metallic Ru sites, while CO_2 derives from CO oxidation on oxidized Ru sites [31]. Mallens et al. [32,33] found differences using Rh versus Pt catalysts, in the selectivity toward CO and H_2 during POM. These differences were attributed to the lower activation energy for methane decomposition on Rh versus that on Pt. Mallens et al. suggested that the catalyst's ability to activate methane determines (1) the product distribution and (2) the concentration of active surface species of oxygen, carbon, and hydrogen. Fathi et al. [34] studied the partial oxidation of methane to syngas over platinum catalysts and proposed that the product distribution is determined by both the concentrations and the types of surface oxygen species present at the catalyst surface. Qin et al. [35] suggested that the support might also influence the concentration of adsorbed oxygen and, as a consequence, the activation of methane and the product distribution. Li et al. [36] studied the effect of gas-phase O_2 , reversibly adsorbed oxygen, and oxidation state of the nickel in the $\text{Ni}/\text{Al}_2\text{O}_3$ catalyst on CH_4 decomposition and partial oxidation using transient response techniques at 700°C . They concluded that the surface state of the catalyst affects the reaction mechanism and plays an important role in POM conversions and selectivities. Li et al. [36] also argued that direct oxidation is the major POM route, and that the indirect oxidation mechanism cannot become dominant under their experimental conditions.

The reaction steps in CH_4 oxidation to CO and H_2 over a $\text{Rh}(1 \text{ wt\%})/\gamma\text{-Al}_2\text{O}_3$ catalyst were studied using in situ DRIFTS at 973 K by Buyevskaya et al. [37,38]. The product distribution and the resulting absorption band intensities of the adsorbates were strongly influenced by oxygen coverage and carbon deposits on the surface. CH_4 was dehydrogenated to deposited carbon and H_2 , while simultaneously being oxidized to CO_2 and H_2O . Surface OH groups in the support were involved in the CH_x conversion to CO via reforming reactions. These authors assumed that surface carbon reacted with CO_2 to contribute to CO formation. Weng et al. [39,40] employed in situ TR-FTIR to investigate partial methane oxidation to syngas over supported Rh and Ru catalysts at 500°C . Their TR-FTIR spectra indicated that a significant difference in POM mechanisms occurred when employing supported Ru versus supported Rh catalysts. CO was the primary POM product over hydrogen-reduced and working-state Rh catalysts according to these TR-FTIR observations. In contrast, CO_2 was the primary POM product over supported Ru catalysts. Therefore, the direct oxidation of CH_4 was proposed as the main pathway with Rh/SiO_2 , while the reforming of unreacted CH_4 to syngas dominated using Ru/SiO_2 and was accompanied by oxidation of a portion of the CH_4 to CO_2 and H_2O .

The present investigation concerns the partial oxidation of methane to syngas over Rh/SiO_2 and Ru/SiO_2 catalysts.

Interaction of CH₄/Ar or CH₄/O₂/Ar with both Rh/SiO₂ and Ru/SiO₂ catalysts was examined by pulse and transient reaction techniques with on-line mass spectrometry monitoring. In situ microprobe Raman spectroscopy was used to study the oxidation state of the catalyst's surface under POM reaction conditions. The catalysts were characterized by TPR, XRD, and H₂ chemisorption. The different results observed over Rh/SiO₂ versus those using Ru/SiO₂ are explained.

2. Experimental

2.1. Catalyst preparation

The supported Rh and Ru catalysts were prepared by solution impregnation. The support SiO₂ (Aldrich Chemical Company, 60–80 mesh, 406 m²/g) was first impregnated with either a RhCl₃·3H₂O or a RuCl₃·3H₂O aqueous solution. The water was evaporated and the solids were dried overnight in a vacuum oven at 110 °C and calcined in air at 500 °C for 6 h. A series of 1.0, 2.0, and 4.0 wt% catalysts were prepared. No chlorine content was detected in either of the catalysts by XPS.

2.2. Catalytic performance tests

Catalytic reaction tests were carried out in a fixed-bed quartz microreactor (200 mm, 6 mm i.d.). A 250-mg catalyst sample was charged. The reaction system was first purged with nitrogen, and the catalyst was reduced under pure hydrogen flow (10 ml/min) at 500 °C for 0.5 h. Then, a mixed CH₄/O₂ gas stream was introduced. The ratio of CH₄/O₂ in the feed gas was held constant at 2.0 (molar ratio). Activity testing was carried out at a GHSV of 1 × 10⁵, 1.5 × 10⁵, and 2 × 10⁵ h⁻¹, 450–800 °C and 1 atm. Analyses of the reactant/product mixtures were conducted on a Model 103G gas chromatograph with a TC detector. A carbon sieve TDX-01 column was used to separate H₂, CO, O₂, CH₄, and CO₂ using argon as the carrier gas. The column was maintained at 110 °C under an argon flow of 30 ml/min. The amount of carbon deposited on the catalysts after POM was obtained via combustion chromatography as previously described [13].

2.3. Temperature-programmed reduction (TPR), temperature-programmed desorption (TPD), pulsed reactions, and transient responses to step changes of the feed gases

TPR, TPD, pulsed reactions, and the transient responses to step changes in the feed gases were each carried out in a fixed-bed tubular quartz microreactor with an inner diameter of 3 mm and 18 cm length. A 50-mg catalyst sample was used in every run. An on-line Balzers quadrupole mass spectrometer (QMS200) continuously monitored the effluent from the reactor. The effluents could contain H₂ ($m/z = 2$),

He ($m/z = 4$), CH₄ ($m/z = 16$), H₂O ($m/z = 18$), CO or N₂ ($m/z = 28$), O₂ ($m/z = 32$), and CO₂ ($m/z = 44$).

2.3.1. TPR experiments

Fresh catalyst was first pretreated in a He flow at 500 °C for 1 h. The sample was then cooled to room temperature and the He flow was switched to a 3% by volume H₂ in N₂ flow. After the effluent concentrations had reached constant values for 30 min, the temperature was ramped at a rate of 15 °C/min to 1000 °C.

2.3.2. O₂-TPD experiments

The catalyst was first pretreated at 700 °C under flowing pure oxygen for 10 min and then cooled to room temperature. Then a He flow was introduced for 30 min. The temperature was next increased at a rate of 20 °C/min to 1000 °C while helium was next passed through the catalyst bed.

The pulse reaction experiments were performed at 700 °C and 1 atm. Helium (30 ml/min) was used as the carrier gas, and 1 ml CH₄/Ar (1/10) per pulse was employed. The sample was continuously exposed to a flow of 30 ml/min He. The desired gas was pulsed into this He stream. The reaction products were quantified with a mass spectrometer.

The transient experiments were performed at 500 and 700 °C under 1 atm. The reactants were CH₄/O₂/Ar (2/1/20).

2.4. In situ microprobe Raman characterization

In situ microprobe Raman catalyst characterization experiments were performed using a home-built high-temperature in situ microprobe Raman cell, allowing Raman spectra of the catalysts to be obtained from room temperature to 700 °C under different gas atmospheres. Raman spectra were recorded on a Dilor LabRam I cofocal microprobe Raman system. The exciting wavelength of 514.5 nm was generated with an Ar⁺ laser with a power of 15 mW and a spot size of ca. 3 μm². The laser beam was focused on the top of the catalyst bed. In each experiment, the catalyst (ca. 2.5 × 10⁻³ ml) was first subjected to a flow of O₂ (99.995%) at 500 °C for 30 min. After O₂ pretreatment, the Raman spectra of the catalysts were obtained. Then the treatment was switched to a H₂/Ar (5/95, molar ratio) flow at 500 or 600 °C for 5 min and the Raman spectra of H₂-reduced sample were obtained. Finally, the H₂-reduced catalyst bed was subjected to a flow of CH₄/O₂/Ar (2/1/45, molar ratio) at 500 or 600 °C for 5 min, and then the Raman spectra of the catalysts were obtained under POM conditions at a flow rate of 5 ml/min. All the Raman spectra were recorded under steady-state conditions.

2.5. X-ray diffraction (XRD) and metal dispersions

XRD patterns were obtained with a Philips PW 1840 powder diffractometer. Co-Kα radiation was employed, covering 2θ between 20 and 80°. Metal dispersions on the catalysts were measured by H₂ chemisorption at room temperature. The percentage dispersion of Rh or Ru metal was calcu-

lated assuming a H/M atomic ratio of 1 [41]. The metal dispersion was estimated by hydrogen chemisorption at room temperature. The catalyst sample was first reduced under hydrogen at 500 °C for 1 h, evacuated at 500 °C under high vacuum for 30 min, and then cooled to room temperature under vacuum for chemisorption.

3. Results

3.1. Catalytic performance

A CH₄/O₂ gas mixture with a molar ratio of 2/1 was used as the feed gas, in POM reactions conducted between 450 and 800 °C at 1 atm, and at a GHSV of 150,000 h⁻¹ over 1 wt% Rh/SiO₂ and 1 wt% Ru/SiO₂. The effect of temperature on catalyst reactivity was investigated. Product distributions, conversions, and selectivities are presented in Table 1.

The conversion of methane and selectivity to syngas both increased with increasing temperature. The conversions and selectivities were high at high temperatures (≥ 700 °C) for both catalysts. But, conversion of CH₄ and O₂ and selectivity of CO and H₂ are obviously different for these two catalysts at low temperatures (450–600 °C). Specifically, the conversion of CH₄ and selectivity to both H₂ and CO over Rh/SiO₂ catalyst were higher than those over Ru/SiO₂. The O₂ conversion was a little lower over Rh/SiO₂ than that over Ru/SiO₂. After completing the POM reactions, combustion chromatography was employed to detect any carbon deposition on the catalysts. However, no evidence for carbon deposition was detected for either catalyst after the POM reaction.

Table 2 shows the effect of space velocity on the CH₄ and oxygen conversions and on syngas selectivities at both 500 and 700 °C. At 500 °C, the CH₄ conversion and the CO

and H₂ selectivities decreased with increasing space velocity over 1 wt% Ru/SiO₂, while on 1.0 wt% Rh/SiO₂ the CH₄ conversion and the CO and H₂ selectivities maintained nearly constant. Both the CH₄ conversions and the CO and H₂ selectivities increased slightly over Rh/SiO₂ at 700 °C as GHSV increases, while the CH₄ conversions and the CO and H₂ selectivities decreased slightly over Ru/SiO₂.

3.2. X-ray diffraction, temperature-programmed reduction (H₂-TPR), and metal dispersions on catalysts

3.2.1. Catalyst XRD patterns

The XRD patterns of 2.0 wt% Rh(O)/SiO₂ and 2.0 wt% Ru(O)/SiO₂ are shown in Fig. 1. The use of (O) indicates these catalysts had been calcined in the presence of oxygen. X-ray diffraction analysis showed that a mixture of Rh₂O₃ and SiO₂ phases was obtained for the 2.0% Rh(O)/SiO₂ catalyst after calcinations. RuO₂ and SiO₂ phases were found on the 2.0 wt% Ru(O)/SiO₂ catalyst. The 1.0 wt% Rh(O)/SiO₂ catalyst was analyzed by XRD (not shown here), but no diffractions corresponding to Rh or Rh₂O₃ were present. Only SiO₂ was detected in Rh(O)/SiO₂. Thus, rhodium particles must be highly dispersed with sizes smaller than the detection limit of the instrument. One of the reasons for this high dispersion is that the rhodium content is very low. XRD of 1.0 wt% Ru(O)/SiO₂ exhibited the SiO₂ phase with very weak RuO₂ lines. The XRD described here was performed on 2.0 wt% metal catalysts.

3.2.2. TPR of catalysts

TPR experiments were conducted from 25 to 500 °C to investigate the reducibility of rhodium oxide and ruthenium oxide on the 1.0% Rh(O)/SiO₂ and 1% Ru(O)/SiO₂ catalysts. Fig. 2 illustrates hydrogen consumption by these

Table 1

Methane and oxygen conversion and the selectivity to H₂ and CO during the partial oxidation of methane over 1.0 wt% Rh/SiO₂ and 1.0 wt% Ru/SiO₂ catalysts^a

Catalyst	Temperature (°C)	Outlet gas composition (%)					Conversion (%)		Selectivity (%)	
		H ₂	O ₂	CH ₄	CO	CO ₂	CH ₄	O ₂	H ₂	CO
1.0 wt% Rh/SiO ₂	450	28.0	8.3	36.5	12.0	15.2	42.7	80.5	51.5	44.1
	500	46.1	3.5	16.5	19.8	14.1	67.2	90.8	68.2	58.4
	550	52.1	1.2	10.5	25.9	10.2	77.5	96.5	72.2	77.5
	600	57.2	0.5	5.9	29.6	6.8	86.0	98.0	78.8	81.3
	650	61.0	0	3.7	30.8	4.5	90.5	100	86.4	87.3
	700	64.0	0	1.9	32.6	1.5	94.7	100	93.8	95.6
	750	64.9	0	1.2	32.8	1.1	96.6	100	95.7	96.7
	800	65.7	0	0.8	33.0	0.5	97.6	100	98.0	98.5
1.0 wt% Ru/SiO ₂	450	25.9	6.0	39.8	9.0	19.3	39.8	88.3	45.7	31.8
	500	43.0	1.6	19.8	18.4	17.2	64.2	93.5	60.4	51.7
	550	50.5	0.7	13.0	23.1	12.7	73.1	97.8	70.8	65.4
	600	54.7	0	8.9	25.9	9.4	83.7	100	76.4	78.5
	650	60.5	0	4.2	30.1	5.2	89.4	100	85.7	85.3
	700	63.6	0	2.0	32.6	1.8	94.3	100	92.4	94.8
	750	64.7	0	1.1	32.9	1.3	96.9	100	94.6	95.6
	800	65.5	0	0.9	32.7	0.9	97.4	100	97.8	97.0

^a Reaction conditions: pressure = 1 atm, CH₄/O₂ = 2/1, GHSV = 150,000 h⁻¹.

Table 2

Effect of gas hourly space velocity (GHSV) on methane conversion and the selectivity to H₂ and CO during the partial oxidation of methane over 1.0 wt% Rh/SiO₂ and 1.0 wt% Ru/SiO₂ catalysts^a

Catalyst	Temperature (°C)	GHSV (h ⁻¹)	CH ₄ conversion (%)		Selectivity (%)	
			CH ₄	O ₂	H ₂	CO
1.0 wt% Rh/SiO ₂	500	100,000	68.8	91.7	69.5	59.1
	500	150,000	67.2	90.8	68.2	58.4
	500	200,000	67.0	90.0	66.2	56.5
	700	100,000	93.5	100	93.4	95.3
	700	150,000	94.7	100	93.8	95.6
	700	200,000	94.6	100	94.7	96.7
1.0 wt% Ru/SiO ₂	500	100,000	66.3	95.1	66.5	57.9
	500	150,000	64.2	93.5	60.4	51.7
	500	200,000	61.1	91.0	53.6	45.4
	700	100,000	94.5	100	91.7	95.3
	700	150,000	94.3	100	92.4	94.8
	700	200,000	93.9	100	91.6	94.6

^a Reaction conditions: pressure = 1 atm, CH₄/O₂ = 2/1.

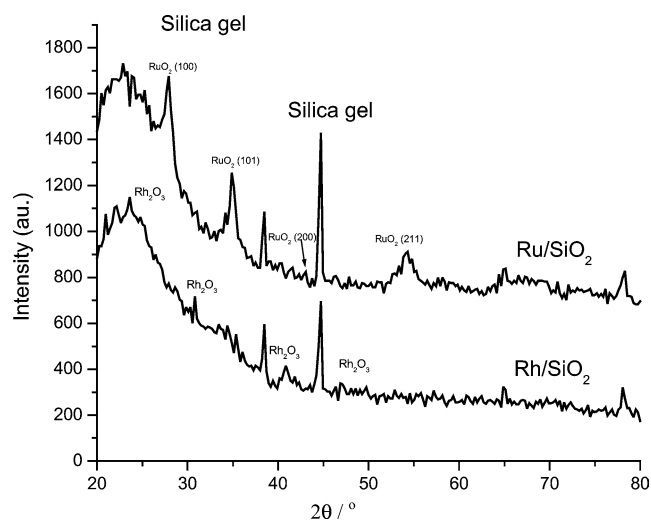


Fig. 1. XRD patterns of Rh/SiO₂ and Ru/SiO₂ catalysts.

catalysts as a function of the temperature during the reduction. Reduction of the 1.0% Rh(O)/SiO₂ catalyst took place between 80 and 180 °C and was characterized by one sharp peak with a maximum temperature around 120 °C. The hydrogen consumption corresponds to a full reduction of rhodium oxide to Rh⁰, i.e., (Rh₂O₃ + 3H₂ → 2Rh + 3H₂O). The reduction profile for 1.0 wt% Ru(O)/SiO₂ exhibited peaks different from those for 1.0% Rh(O)/SiO₂. Two reduction peaks were found in reductions of 1.0% Ru(O)/SiO₂ between 80 and 250 °C. These two peaks had $T_{\max} = 150$ °C and $T_{\max} = 200$ °C, with the latter accounting for significantly more hydrogen uptake. The lower temperature (150 °C) TPR peak has been assigned to the reduction of well-dispersed RuO_x species [42], and the high-temperature peak is attributed to the reduction of RuO₂ particles (RuO₂ + 2H₂ → Ru + 2H₂O) [43]. The hydrogen consumption for 1.0% Ru(O)/SiO₂, calculated from the area of the reduction peak, was about three times that of 1.0% Rh(O)/SiO₂. About 4.9×10^{-6} mol Rh or Ru

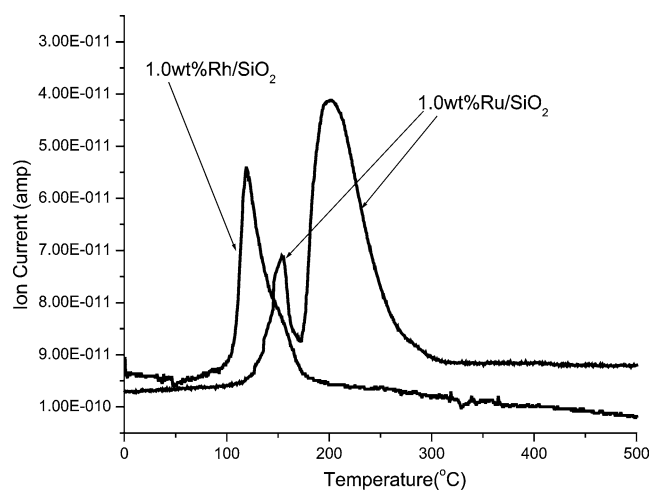


Fig. 2. Temperature-programmed reduction (TPR) profiles of the 1 wt% Rh/SiO₂ catalyst and the 1 wt% Ru/SiO₂ catalyst.

atoms are present in 50-mg samples of these catalysts. Thus, the 1.0 wt% Rh(O)/SiO₂ catalyst must consume 7.29×10^{-6} mol H₂ in TPR reactions if all the rhodium were present as Rh₂O₃ and all Rh₂O₃ is completely reduced to Rh⁰ and H₂O. Similarly, 1.0 wt% Ru(O)/SiO₂ should consume 9.9×10^{-6} mol H₂ if all RuO₂ were reduced.

3.2.3. Metal dispersions

The metal dispersion of the reduced catalysts was obtained by H₂ chemisorption at 298 K. The percentage dispersion of Rh or Ru metal, calculated assuming a H/M atomic ratio of 1, is shown in Table 3. The dispersion of rhodium was 95% for 1.0 wt% Rh/SiO₂ and ruthenium dispersion was 33% for 1.0 wt% Ru/SiO₂. The dispersion of Ru/SiO₂ is much less than that of Rh/SiO₂. The dispersions for both the 2% Rh and 2% Ru catalysts were about half of those found in the 1% Rh and Ru catalysts, respectively.

Table 3
The metal dispersion of the catalysts

Catalyst	H/M (atomic ratio)	Dispersion (%)
1.0 wt% Rh/SiO ₂	0.95	95
2.0 wt% Rh/SiO ₂	0.50	50
1.0 wt% Ru/SiO ₂	0.33	33
2.0 wt% Ru/SiO ₂	0.15	15

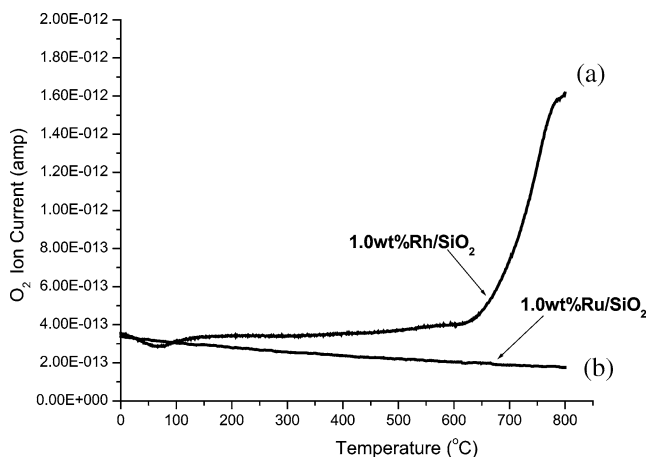


Fig. 3. O₂-TPD profile of (a) the 1 wt% Rh/SiO₂ catalyst and (b) the 1 wt% Ru/SiO₂ catalyst.

3.3. Temperature-programmed desorption of O₂ (O₂-TPD)

O₂-TPD experiments were carried out to characterize the metal oxides in Rh(O)/SiO₂ and Ru(O)/SiO₂. Both catalysts were oxidized under a pure oxygen flow (10 ml/min) at 700 °C for 30 min and then cooled to room temperature before the TPD experiments were conducted. O₂-TPD of the two catalysts is depicted in Fig. 3. O₂ started to desorb from the 1.0 wt% Rh(O)/SiO₂ catalyst around 550 °C and the desorption peak maximum was reached at ca. 800 °C, where the reaction $2\text{Rh}_2\text{O}_3 \rightarrow 4\text{Rh} + 3\text{O}_2$ may occur. No oxygen desorption peak occurred during O₂-TPD of 1 wt% Ru(O)/SiO₂, perhaps because the reaction $3\text{RuO}_2 \rightarrow \text{Ru} + 2\text{RuO}_3$ (or RuO₄) takes place instead at high temperatures [44].

3.4. Interaction of methane with the catalysts by pulsed reactions

Oxygen-free CH₄ pulsing reactions were carried out over both 1.0 wt% Rh/SiO₂ and 1.0 wt% Ru/SiO₂ at 700 °C and 1 atm pressure. The CO and CO₂ produced are shown in Fig. 4. Fig. 4a depicts the CO and CO₂ formation responses during CH₄ pulsing over unreduced Rh(O)/SiO₂. Large amounts of CO and CO₂ were observed at the first pulse. The formation of CO and CO₂ may result from CH₄ reacting with the active oxygen species on the Rh and/or SiO₂ support surface. However, no CO₂ formation was observed after the first pulse. The concentration of oxygen species on the catalyst surface might be too low after the

first pulse to form CO₂. Readily observed tailing of the CO peak occurred after each CH₄ pulse. The CO tailed for 2–3 min before reaching background level, while CO₂ peaks lasted only 5–6 s. We suggest that adsorbed CH_x ($x = 0-3$) reacts with oxygen species to form CO, while CO₂ might come from total oxidation methane ($3\text{CH}_4 + 4\text{Rh}_2\text{O}_3 \rightarrow 8\text{Rh} + 3\text{CO}_2 + 6\text{H}_2\text{O}$).

The production of CO₂ and CO in CH₄ pulses over reduced Rh/SiO₂ at 700 °C is shown in Fig. 4b. Similar to the response of oxidized Rh(O)/SiO₂, the intensities of CO and CO₂ are high during the first pulse reduced over Rh/SiO₂. CO₂ appears also only at the first pulse over the reduced Rh/SiO₂. No CO₂ is detected after the first pulse. The amount of CO produced was much lower than that formed with Rh(O)/SiO₂. CO peaks tailed when produced by methane pulsing over both the oxidized Rh(O)/SiO₂ and the reduced Rh/SiO₂ catalysts.

CH₄ pulsing over the unreduced Ru(O)/SiO₂ also produces CO and CO₂ (Fig. 4c). Large amounts of CO and CO₂ were detected in the first pulse, and the intensity was much stronger than that found in the evolution of CO and CO₂ from the Rh/SiO₂ catalyst. However, unlike the Rh/SiO₂ catalyst, CO₂ is formed at every pulse over the Ru(O)/SiO₂ catalyst. Pulsing CH₄ over reduced Ru/SiO₂ also produced both CO and CO₂ with every pulse (Fig. 4d). The reaction ($2\text{RuO}_2 + \text{CH}_4 \rightarrow 2\text{Ru} + \text{CO}_2 + 2\text{H}_2\text{O}$) will take place over Ru/SiO₂. These products are very similar to those formed over the unreduced Ru/SiO₂, except that the intensities of the CO and CO₂ peaks are higher than those from reduced Ru/SiO₂. Tailing of the CO peak is also observed during pulsing over Ru/SiO₂ and the tailing time varies from 2 to 3 min. No CO₂ tailing occurs.

Pulse methane reactions were conducted over Rh/SiO₂ and Ru/SiO₂ catalysts without added oxygen (Fig. 4a–4d). Any methane oxidation in these experiments must be derived from oxygen originating from the solid catalyst systems. In each pulse experiment, 1 ml of reactants (CH₄/Ar = 1/10) was introduced. Each 1 ml contains about 4.46×10^{-6} mol methane. If all the Rh is present as Rh₂O₃, the unreduced Rh/SiO₂ catalyst will consume ca. 1.82×10^{-6} mol CH₄. Similarly, the unreduced Ru/SiO₂ should consume 2.50×10^{-6} mol CH₄ if all the Ru is present as RuO₂. So a single CH₄/Ar pulse of 1 ml would be sufficient to reduce all the rhodium and ruthenium oxides (~ 1.0 wt%, ca. 4.9×10^{-6} mol) in each of these 50-mg catalyst samples to the metallic state.

3.5. Transient reactions of CH₄/O₂/Ar with the catalysts

Transient experiments were performed at 500 and 700 °C under 1 atm using step changes in the feed gas from He to CH₄/O₂/Ar. The responses of the product distribution to these step changes, where oxygen has now been added, are shown in Fig. 5.

Fig. 5a plots the responses to a step change in the feed gas from helium to CH₄/O₂/Ar over unreduced Rh(O)/SiO₂

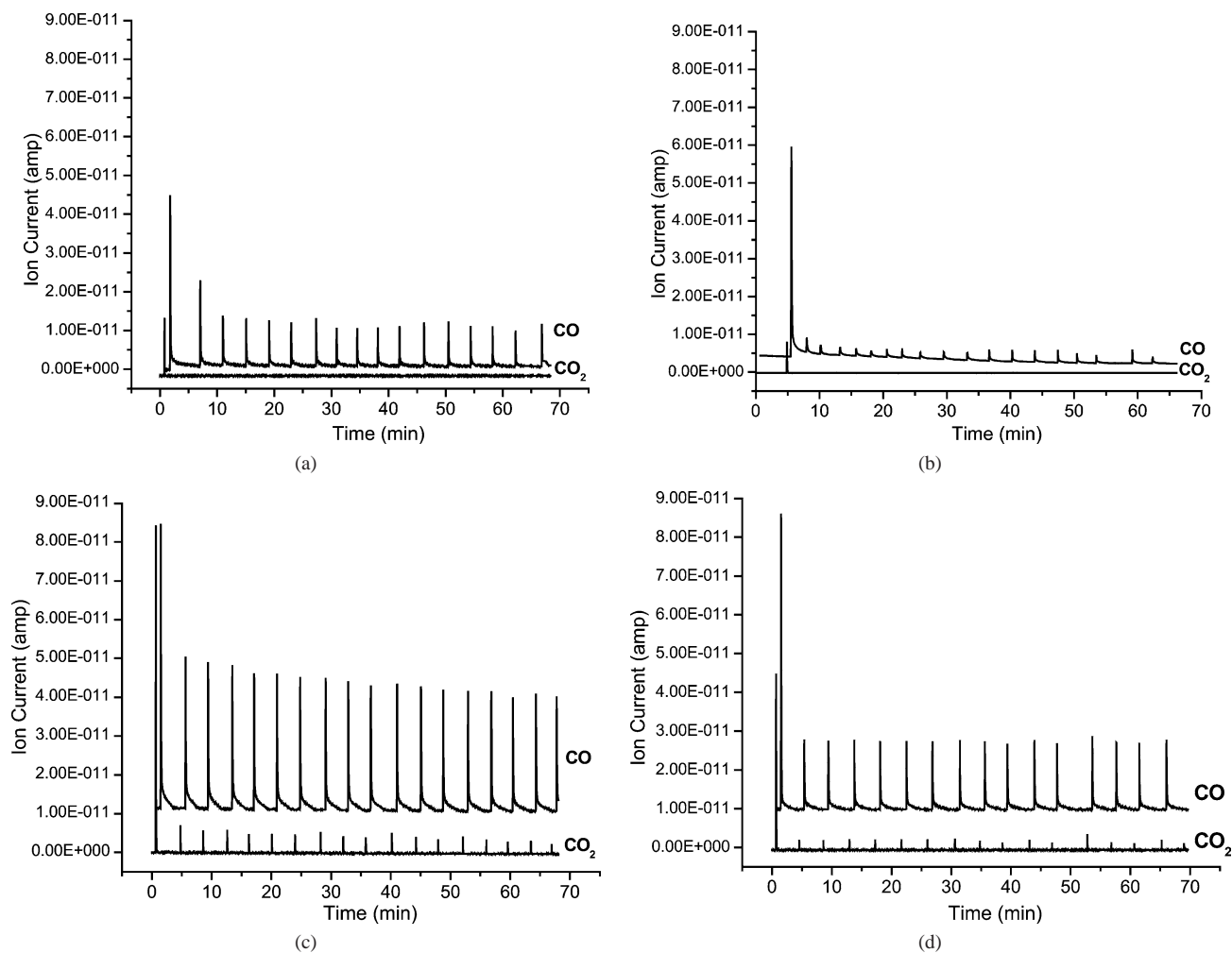


Fig. 4. CO and CO₂ produced by pulsing CH₄ at 700 °C over (a) the preoxidized Rh(O)/SiO₂, (b) the prerduced Rh/SiO₂, (c) the preoxidized Ru(O)/SiO₂, and (d) the prerduced Ru/SiO₂ catalyst.

at 500 °C. It is obvious that CO₂ (4.0 s) appears before CO (4.5 s).

Fig. 5b plots the products versus time as the step change from helium to CH₄/O₂/Ar was made at 500 °C over the reduced Rh/SiO₂. This Rh/SiO₂ catalyst had been previously subjected to a 30 min reduction by H₂ at 500 °C. CO and CO₂ appear at the same time (3.7 s) and then increase to a steady level after the gas feed switch.

Fig. 5c plots the product responses to changing the feed gas from helium to CH₄/O₂/Ar over oxidized Rh(O)/SiO₂ at 700 °C. CO (2.7 s) appears at once and sharply increases to a steady level. CO appears slightly before CO₂ (4.0 s). The amount of CO₂ increases to a steady state level but the quantity of CO₂ formed is much lower than the amount of H₂ and CO generated.

The responses of the step change in the feed gases from helium to CH₄/O₂/Ar were also obtained over the reduced Rh/SiO₂ catalyst (Fig. 5d) which had been previously subjected to a flow of H₂ for 30 min at 700 °C. CO (3.9 s) and H₂ appear immediately after the change from He to CH₄/O₂/Ar was made at 700 °C. The amounts of H₂ and CO increase

sharply to reach their maximum and then decrease slowly to a constant level. Only a very tiny quantity of CO₂ was detected (5.0 s) after the step change.

The product responses to a feed gas change from He to CH₄/O₂/Ar over unreduced Ru(O)/SiO₂ at 500 °C are shown in Fig. 5e. CO₂ appeared at 2.6 s after this step change, while CO appeared at 3.0 s. Fig. 5f depicts the transient product response to the feed gas step change over the reduced Ru/SiO₂ catalyst at 500 °C. The CO₂ (3.3 s) appears prior to CO (4.5 s).

The product responses to a feed gas change from He to CH₄/O₂/Ar over unreduced Ru(O)/SiO₂ at 700 °C are shown in Fig. 5g. CO₂ (2.2 s) appears before CO (4.2 s) after the step change. This contrasts with the behavior induced by the oxidized Rh(O)/SiO₂ catalyst at 700 °C. Furthermore, CO₂ reaches a maximum first and then decreases rapidly to the background level. CO is rapidly formed, rising quickly followed by a long gradual further increase.

Fig. 5h depicts the transient product response to the He to CH₄/O₂/Ar step change over the reduced Ru/SiO₂ catalyst at 700 °C. CO₂ (3.0 s) still appears prior to CO (3.6 s); how-

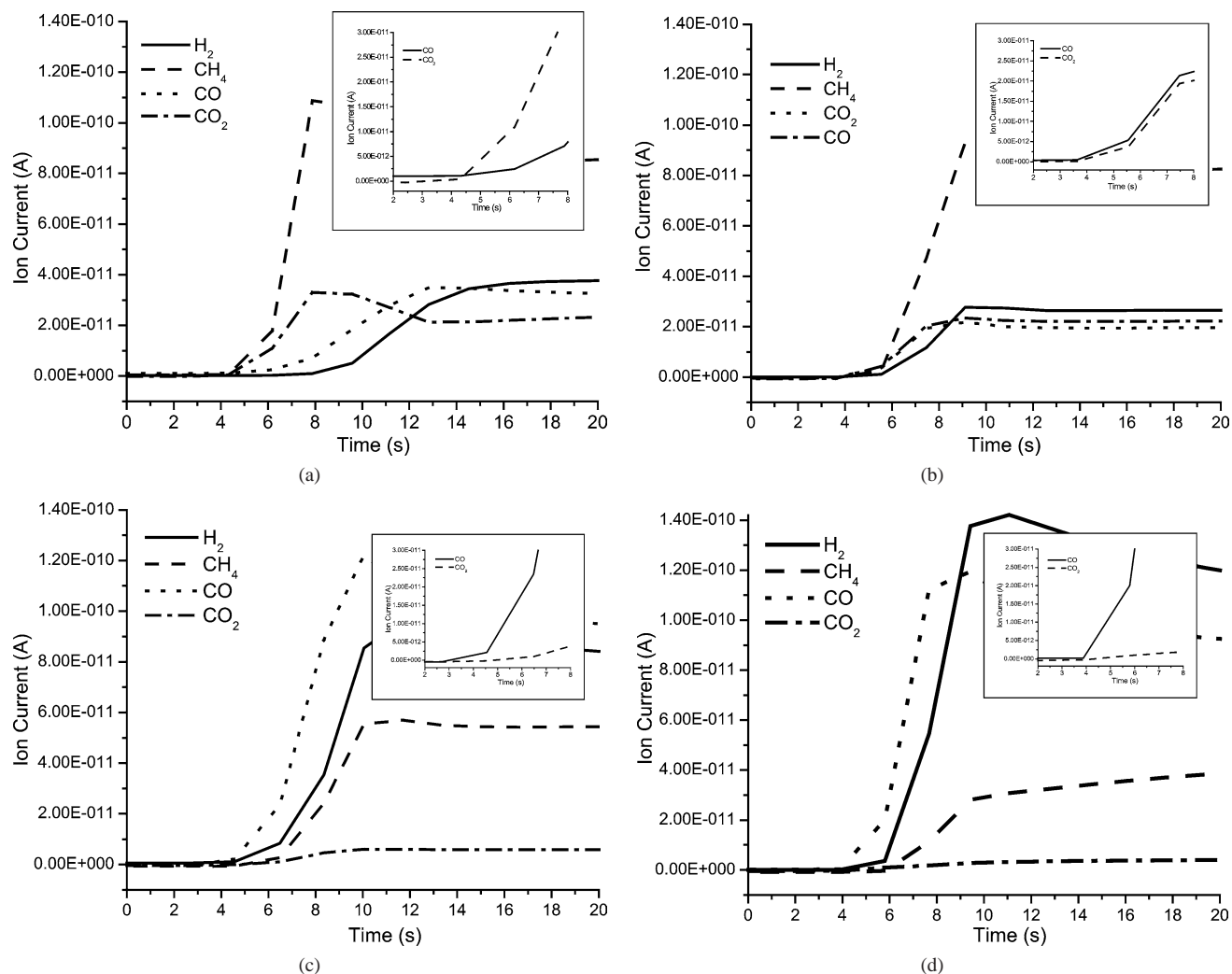


Fig. 5. Transient responses upon a step change in feed gas from He to CH₄/O₂/Ar at 500 and 700 °C over (a) preoxidized Rh/SiO₂ at 500 °C, (b) prerduced Rh(O)/SiO₂ at 500 °C, (c) preoxidized Rh/SiO₂ at 700 °C, (d) prerduced Rh(O)/SiO₂ at 700 °C, (e) preoxidized Ru(O)/SiO₂ at 500 °C, (f) prerduced Ru/SiO₂ at 500 °C, (g) preoxidized Ru(O)/SiO₂ at 700 °C, and (h) prerduced Ru/SiO₂ at 700 °C.

ever, only very small quantities of CO₂ were found to form over reduced Ru/SiO₂ catalyst.

3.6. *In situ* microprobe Raman spectroscopy

The Raman spectrum of 4 wt% Rh/SiO₂ was recorded at 500 °C under an O₂ flow (Fig. 6a). A broad band centered at 491 cm⁻¹. It was attributed to Rh₂O₃ [42]. Many studies of Rh catalysts have proved that complete oxidation of Rh to Rh₂O₃ takes place under an O₂ atmosphere at temperatures above 500 °C [45]. The Rh₂O₃ band at 491 cm⁻¹ disappeared when the O₂-pretreated Rh/SiO₂ sample was reduced in a flow of H₂/Ar at 500 °C. No Rh₂O₃ 491 cm⁻¹ band appeared when the H₂/Ar pretreated Rh/SiO₂ was switched to a flow of CH₄/O₂/Ar at the same temperature. Thus, surface oxides of rhodium do not form in observable quantities under POM conditions at 500 °C. At higher temperatures the thermal desorption of oxygen from rhodium surfaces was shown to become more pronounced

(Section 3.3). Thus, metallic rhodium surfaces are available from 500 to 800 °C. The Raman spectrum of 4 wt% Ru/SiO₂ catalyst was recorded at 600 °C under O₂ (Fig. 6b). Two bands attributable to ruthenium oxide appear at 489 and 609 cm⁻¹ [46,47]. These bands vanished when the O₂-pretreated 4 wt% Ru/SiO₂ was subsequently placed under a flow of H₂/Ar at 600 °C, and then these bands reappeared when a flow of CH₄/O₂/Ar gases was introduced at the same temperature. Thus, oxides of ruthenium form on the catalyst under POM conditions at 600 °C.

4. Discussion

4.1. Characterization of Rh/SiO₂ and Ru/SiO₂ catalysts and effects of oxidation states on POM mechanism over Rh/SiO₂ and Ru/SiO₂ catalysts

Rh₂O₃ is the most stable oxide of rhodium [48]. Complete oxidation of Rh to Rh₂O₃ occurs above 500 °C un-

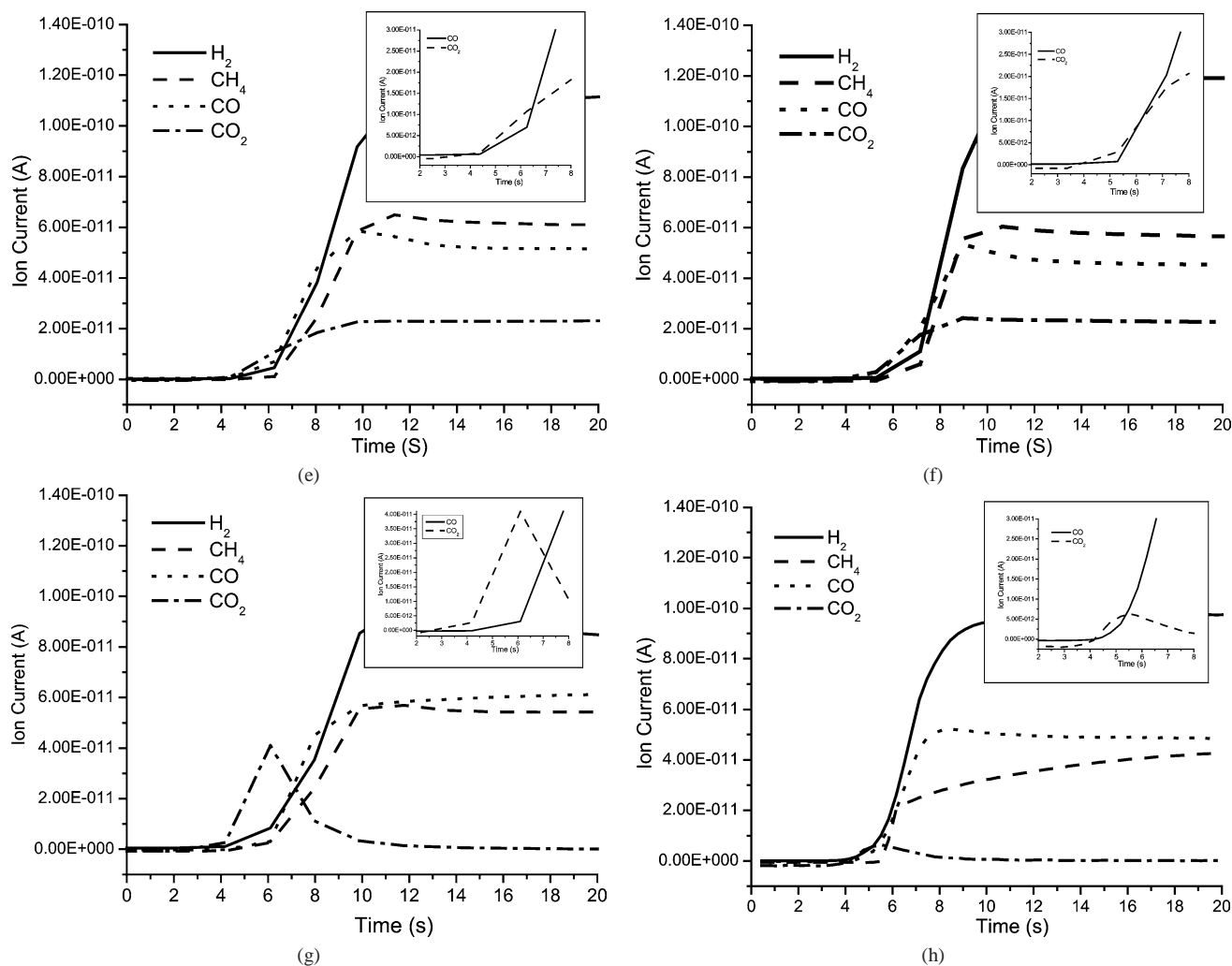


Fig. 5. Continued.

der an O₂ atmosphere. Rh₂O₃ thermally decomposes only at 1100 °C [49], but it easily reduces with hydrogen at 200 °C [50]. Facile reduction of Rh(O)/SiO₂ by H₂ was observed at 120 °C in TPR experiments (Fig. 2). Ruthenium oxides including Ru₂O₃, RuO₂, RuO₃, and RuO₄ are more resistant to reduction than Rh₂O₃ [51]. The reduction of 1 wt% Rh(O)/SiO₂ takes place between 80 and 180 °C with the H₂ uptake peak occurring at $T_{\max} = 120$ °C (Fig. 2). In contrast, Ru(O)/SiO₂ exhibits two hydrogen uptake peaks, with the smaller peak maximizing at 150 °C and the larger at 200 °C. A single reduction peak from Rh(O)/SiO₂ is consistent with excellent surface dispersion of the rhodium oxides on SiO₂. The two peaks (150 and 200 °C) in the TPR profile of Ru(O)/SiO₂ suggest the presence of two different ruthenium oxides [42] where Ru–O bonding is stronger than rhodium–oxygen bonding. The 150 °C TPR peak has been assigned to the reduction of well-dispersed RuO_x species [42], while the high-temperature peak is attributed to the reduction of RuO₂ particles ($\text{RuO}_2 + 2\text{H}_2 \rightarrow \text{Ru} + 2\text{H}_2\text{O}$) [43].

Different surface metal oxidation states and/or the relative bond strengths of transition metals with oxygen can result in different mechanisms [32,33,35]. Stronger M–O bond strengths give more stable transition metal oxides. This could lead to differences in activity and mechanism during POM.

CH₄ pulse experiments provide some mechanistic insight. A noticeable difference was observed in the reaction of pure methane over the unreduced versus the reduced 1.0 wt% Rh and Ru catalysts at 700 °C. CO is both the direct product and the major product over unreduced and reduced 1.0 wt% Rh/SiO₂. This result is in accord with previous in situ time-resolved FTIR spectroscopy studies [39,40], in which CO was the primary POM reaction product over both reduced Rh metal and working state Rh/SiO₂ catalysts. In contrast, CO₂ is a primary product during POM over Ru/SiO₂. CO₂ was formed in every pulse when oxygen-free CH₄ was pulsed over Ru/SiO₂ at 700 °C. Therefore, it is clear that the oxygen, contained in the ruthenium oxides, was responsible for both CO₂ and CO formation occurring over Ru/SiO₂. In contrast, CO₂ was only formed during the first

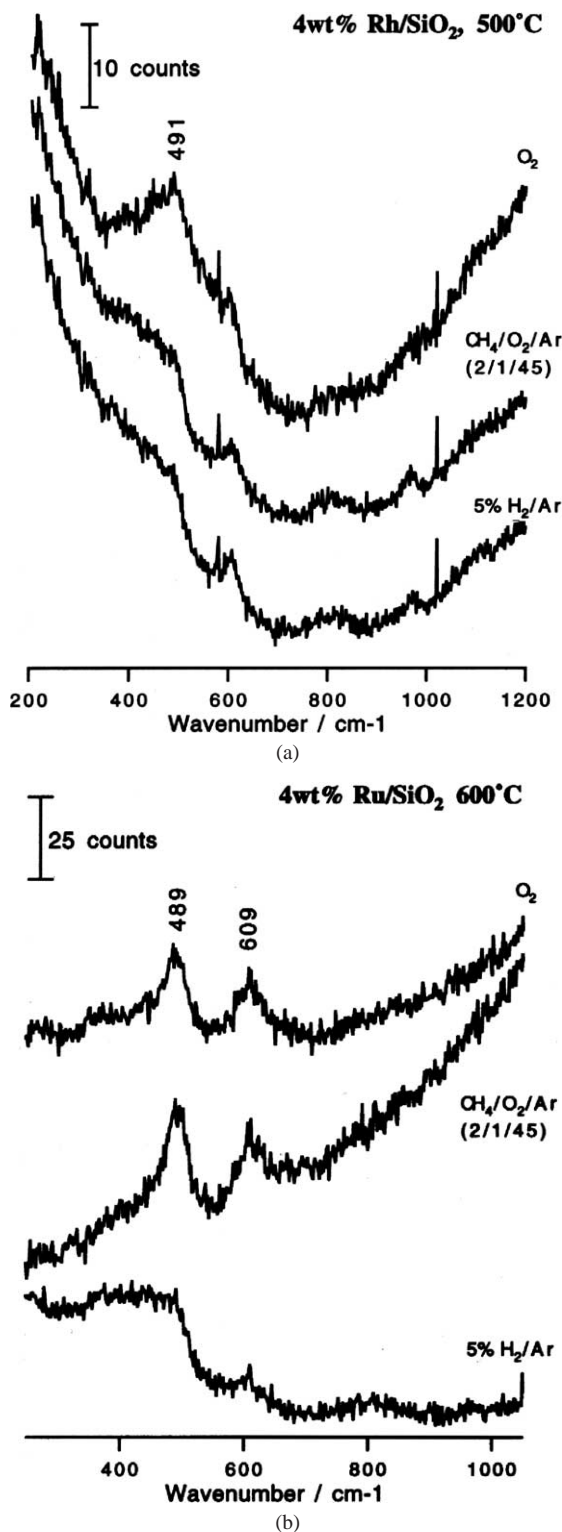


Fig. 6. In situ Raman spectra of (a) 4 wt% Rh/SiO₂ at 500 °C and (b) 4 wt% Ru/SiO₂ at 600 °C when each of these catalysts was under O₂, CH₄/O₂/Ar (2/1/45), or 5% H₂/95% Ar.

pulse and never thereafter when methane was pulsed over Rh/SiO₂. Thus, surface oxygen on rhodium sites favors the formation of CO. Apparently, the very small rhodium oxide surface concentration is too low to continue to fully oxidize

CH_x species on the rhodium catalyst's surface to CO₂ before CO desorbs. Thus, the amount and state of the metal oxides present on the Rh/SiO₂ and Ru/SiO₂ catalysts are of seminal importance to the methane activation pathway and the product distribution.

CO is the primary product over Rh/SiO₂ catalysts after the change from He to CH₄/O₂/Ar was made at 700 °C for the transient reaction (Fig. 5c and 5d) and only a very tiny amount of CO₂ was detected. CO₂ is the primary product for both preoxidized and prerduced Ru/SiO₂ catalysts at 500 and 700 °C, implying that the concentration of oxygen species on the catalyst may have a significant influence on the reaction schemes for POM. Based on TAP (temporal analysis of products) studies of POM over individual metal or supported metal catalysts, such as Rh sponge [52], Rh/Al₂O₃ [52,53], and Pt gauze [32], some researchers have concluded that the formation of primary products depends on the amount/concentration of oxygen species on the catalyst surface. This suggests that the amount of oxygen on Rh/SiO₂ surfaces where direct oxidation of methane to syngas occurs will be less than that on Ru/SiO₂ surfaces where the POM occurs via an indirect combustion/reforming mechanism.

In situ microprobe Raman spectroscopy characterization of the 4 wt% preoxidized Rh/SiO₂ surface exhibited the loss within 2 min of the broad 491 cm⁻¹ band of Rh₂O₃ (found at 500 °C under O₂) [42], when the gas flow was switched to H₂/Ar at 500 °C. The Raman spectrum of this catalyst recorded under a simulated POM feed (CH₄/O₂/Ar = 2/1/45) is very similar to that recorded under the H₂/Ar atmosphere. No Rh₂O₃ was detected. Similar spectra were obtained when heating the catalyst in a CH₄/O₂/Ar between 500 and 600 °C. Clearly, most of the Rh species over the Rh/SiO₂ are in the metallic state during POM. Mallens et al. [32] reached the same conclusion from their TAP experiment, where by assuming the Rh₂O₃ oxide stoichiometry, only 0.4 wt% of Rh₂O₃ is present during the simultaneous interaction of CH₄ and O₂ at a stoichiometric feed ratio (CH₄/O₂ = 2/1) over the rhodium sponge.

Raman bands (489 and 609 cm⁻¹) attributed to RuO₂ [46,47] were observed for the 4 wt% Ru/SiO₂ under O₂ at 500 to 600 °C. These bands disappeared when the preoxidized 4 wt% Ru/SiO₂ was exposed to H₂/Ar at 500 to 600 °C and reappeared when the H₂/Ar pretreated Ru/SiO₂ was switched to a flow of CH₄/O₂/Ar at the same temperature. Thus, the Ru species of the Ru/SiO₂ catalyst are almost fully oxidized under the POM conditions. In situ microprobe Raman characterizations of Rh/SiO₂ and Ru/SiO₂ catalyst (Fig. 6) under POM conditions correspond to pulse and transient reaction results, showing that a significant difference in mechanism exists over these two catalysts. The concentration of oxygen species on the catalyst surface causes the mechanistic change. No Raman band of Rh₂O₃ species was detected in a working-state Rh/SiO₂. Even at the top of the catalyst bed, most of the Rh is in the metallic state during POM. CH₄ is activated and dissociated to CH_x (x = 0–3)

species on Rh^0 sites and then converted to CO through surface reactions, such as H dissociation from CH_x and the oxidation of surface C or CH_x ($x = 1\text{--}3$) species by surface oxygen species (e.g., O^{2-}).

In contrast to Rh/SiO_2 , the Ru species on Ru/SiO_2 near the entrance of the catalyst bed are almost fully oxidized under the reaction conditions. Transient and pulse reactions show that oxidized Ru species catalyze the complete oxidation of CH_4 to CO_2 , causing complete oxygen consumption from the feed (CH_4/O_2) within a narrow zone at the entrance of the catalyst bed. Ru located in the rest of catalyst bed is reduced by the CH_4 remaining in the feed to the metallic state. Reforming of the resulting $\text{CH}_4/\text{CO}_2/\text{H}_2\text{O}$ to syngas occurs at such reduced Ru sites. The oxygen species on the catalysts could be surface O^{2-} . Surface O^{2-} is responsible for both the selective and complete oxidation of methane, depending on its concentration. The significant catalytic differences of Rh/SiO_2 and Ru/SiO_2 may be related to the large differences in the $\text{Rh}\text{--}\text{O}$ (405.0 kJ/mol) and $\text{Ru}\text{--}\text{O}$ (528.4 kJ/mol) bond strengths [54]. This renders the reduction of Ru/SiO_2 more difficult than that for Rh/SiO_2 . For example, temperature-programmed reductions (Fig. 2) demonstrate a lower reduction temperature for 1 wt% Rh/SiO_2 relative to 1 wt% Ru/SiO_2 . The $\text{Ru}(\text{O})/\text{SiO}_2$ surface chemistry differs from that of $\text{Rh}(\text{O})/\text{SiO}_2$. O_2 dissociates to form $\text{Ru}\text{--}\text{O}$ species on metallic Ru sites, eventually generating a RuO_2 surface phase that is not easily decomposed. RuO_2 inhibits C–H dissociation, desorption of CH_x , and reaction of CH_x fragments with dissociatively adsorbed oxygen. The high surface RuO_2 concentration on Ru/SiO_2 during low-temperature (450–600 °C) POM contrasts sharply with the surface composition of Rh/SiO_2 . CH_4 cannot dissociate over metallic ruthenium sites and so cannot react via a direct surface oxidation process. However, CH_4 can be oxidized via a nonselective indirect mechanism [55] ($\text{CH}_4 + 2\text{RuO}_2 \rightarrow \text{CO}_2 + 2\text{H}_2\text{O} + 2\text{Ru}^0$) where CO_2 is a primary product over the ruthenium catalyst. Therefore, POM over Ru/SiO_2 occurs mainly via an indirect nonselective oxidation process. The selectivity of Ru/SiO_2 is lower than that of Rh/SiO_2 .

The low $\text{Rh}\text{--}\text{O}$ bond strength leads to a much lower surface oxygen coverage on Rh/SiO_2 catalyst during POM. Surface oxygen on oxidized $\text{Rh}(\text{O})/\text{SiO}_2$ begins to thermally desorb at 550 °C according to the O_2 -TPD experiments (Fig. 3). Reduction of rhodium oxides started at 80 °C and peaked at 120 °C in TPR experiments, so the Rh/SiO_2 surface must be metallic Rh during POM since H_2 is present. Consequently, partial oxidation of CH_4 to syngas over Rh/SiO_2 proceeds mainly via a direct oxidation [56,57], in which CH_4 and O_2 react at the metal surface via their dissociated and adsorbed species.

The gas hourly space velocity (GHSV) $\text{CH}_4/\text{O}_2 = 2/1$ (Table 2) has little effect on the performance of Rh/SiO_2 at 500 °C when increased from 100,000 to 150,000 h^{-1} . The CH_4 conversion and selectivities to H_2 and CO decreased slightly, CH_4 conversion from 68.8 to 67.0%, CO selectivity from 59.1 to 56.5%, and H_2 selectivity from 69.5 to 66.2%.

A more significant effect on Ru/SiO_2 occurred when GHSV increased from 100,000 to 150,000 h^{-1} . Methane conversion decreased from 66.3 to 61.1%; CO selectivity dropped from 57.9 to 45.4%, and H_2 selectivity reduced from 66.5 to 53.6%. These results also support direct oxidation with Rh/SiO_2 and indirect combustion/reforming over Ru/SiO_2 , in agreement with POM mechanisms proposed based on the in situ micro-Raman, pulse and transient reactions studies.

4.2. Primary product determination by transient reactions

A main concern in the POM mechanism debate is whether CO_2 or CO is the primary product. For the direct oxidation scheme, CO is the primary product whereas CO_2 should be formed prior to CO in the indirect process. The TAP reactor has been used to monitor CO and CO_2 formation during the POM reaction [25,32–34,37,38,52,53,58,59]. Responses to pulses of O_2 , CH_4 , or CH_4/O_2 over catalysts under different conditions have provided mechanistic information. Most TAP studies focused on the POM over platinum and rhodium. No TAP study of POM with a ruthenium catalyst has been reported, although Ru supported on TiO_2 is an effective catalyst for POM via a direct route [22,31,60,61]. Mechanistic results from TAP studies of a similar catalyst still do not agree about the primary reaction products [32,38]. Weng et al. [39,40] used in situ TR-FTIR spectroscopy to follow the primary products over SiO_2 -supported rhodium and ruthenium catalysts from 500 to 600 °C. CO was the primary POM product over hydrogen-reduced and working-state Rh catalysts. In contrast, CO_2 was the primary POM product over supported Ru catalysts. Therefore, direct oxidation of CH_4 was proposed with Rh/SiO_2 , while the reforming of unreacted CH_4 to syngas dominated using Ru/SiO_2 . This was accompanied by oxidation of a portion of the CH_4 to CO_2 and H_2O .

Transient reactions (Fig. 5) were used in the current study to determine the primary POM products over SiO_2 -supported rhodium and ruthenium catalysts at temperatures at 500 and 700 °C. When O_2 -pretreated 1 wt% Rh/SiO_2 was subjected to a step change from helium to $\text{CH}_4/\text{O}_2/\text{Ar}$ (2/1/45) at 700 °C, CO appeared before CO_2 (Fig. 5c). Similar results were obtained for prerduced Rh/SiO_2 (Fig. 5d). These results agree with the TAP study of POM at 600 °C over unsupported Pt and Rh catalysts by Mallens et al. [32,33] where direct oxidation of CH_4 occurred upon pulsing with O_2 , CH_4 , or CH_4/O_2 . At comparable temperatures, the Rh catalyst shows a higher methane conversion and greater selectivity to both CO and H_2 than Pt. Fathi et al. [34] also showed that POM could be attributed to a direct mechanism using a TAP-2 reactor over Pt gauze at temperatures above 800 °C. In this current study, transient reactions prove that CO_2 is the primary POM product over both preoxidized and prerduced 1 wt% Ru/SiO_2 at 500 and 700 °C. CO is only detected after CO_2 . CO results from combustion of CH_4 to CO_2 and H_2O , followed by reforming. Buyevskaya et al. [25,38], Guerrero-Ruiz et al. [62], and

Boucoulvalas et al. [63] came to a similar conclusion about POM based on in situ diffuse reflectance infrared Fourier transform spectroscopy (DRIFTS), kinetics, and isotopic tracing and TAP reactor studies.

5. Conclusions

Methane conversion and selectivity to both H₂ and CO were higher over Rh/SiO₂ than Ru/SiO₂. The CO and H₂ selectivities substantially decreased with increasing GHSV over Ru/SiO₂ at 500 °C but remained nearly constant over Rh/SiO₂. Both the CH₄ conversions and the CO and H₂ selectivities increased slightly over both catalysts at 700 °C as GHSV increases, while the CH₄ conversions and the CO and H₂ selectivities decreased slightly. CO was the main product at 700 °C when Rh/SiO₂ was exposed to methane pulses, whether the catalyst was preoxidized or prereduced. CO₂ was only detected during the first pulse over Rh/SiO₂ catalyst. More CO₂ was formed over Ru/SiO₂ than Rh/SiO₂ during the first pulse; CO₂ was formed at every pulse over Ru/SiO₂.

CO formed before CO₂ over preoxidized or prereduced Rh/SiO₂ at 700 °C in transient reactions, induced by changing the feed gas from helium to CH₄/O₂/Ar. CO₂ is the primary product over Ru/SiO₂ catalysts during transient reactions.

In situ microprobe Raman spectroscopy demonstrated that the oxide levels present on Ru/SiO₂ were far higher during POM than those on Rh/SiO₂. The mechanisms of POM over these two catalysts are different. On the Rh/SiO₂ catalyst, POM is mainly a direct oxidation process, while on the Ru/SiO₂ catalyst, the dominant pathway of POM is the indirect oxidation process.

Acknowledgments

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